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Applicant

MOEHWALD et al.

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Group Art Unit

Unknown

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## U.S. PATENT DOCUMENTS

Exam. Init.	Document Number	Date	Name	Class	Sub- Class	Filing Date
Sw	5,073,611	12/17/91	Rehmer et al.	526	208	
Sw	5,622,792	4/22/97	Brochu et al.	429	192	
ZW	5,420,204	5/30/95	Valet et al.	525	125	
Sw	5,128,386	7/7/92	Rehmer et al.	522	35	
Sw	5,296,318	3/22/94	Gozdz et al.	429	192	
Sw	5,429,891	7/4/95	Gozdz et al.	429	192	
Sw	4,241,149	12/23/80	Labes et al.	429	50	
Sw	5,098,973	3/24/92	Kozuka et al.	526	282	
ZW	5,558,911	9/24/96	Blum	427	517	
Sw	5,486,435	1/23/96	Brochu et al.	429	192	

## FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Sub- Class	Filing Date
Sw	DE 196 53 631	6/25/98	Germany			
Sw	DE 44 33 290	3/21/96	Germany			
Sw	DE 196 12 769 *	10/2/97	Germany			

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Sw	G. Eisele et al. "Mécanisme de photoréticulation de polymères contenant le motif dicyclopentadiène en présence et absence de benzophénone" Macromolecular Chem. Vol. 197, (1996) pgs 1731-1756				
Ull	Ullmann's Encyclopedia of Industrial Chemistry 5th Ed., Vol. A3 pgs 343-397				
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